

Electronic Patent Application Fee Transmittal

Application Number:	10655699			
Filing Date:	05-Sep-2003			
Title of Invention:	METHOD OF DEPOSITING A SILICON DIOXIDE-COMPRISING LAYER IN THE FABRICATION OF INTEGRATED CIRCUITRY			
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Attorney Docket Number:	MI22-2307			
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Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Certificate of correction	1811	1	100	100
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Total in USD (\$)				100